

**Search Notes**

Application/Control No.

10/618,541

Examiner

Richard H. Kim

Applicant(s)/Patent under  
Reexamination

HWANG

Art Unit

2871

**SEARCHED**

Class	Subclass	Date	Examiner

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
East Search (jpo,epo,uspat,pgpub)	12/26/2007	RHK